

INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional)

TSMC - 01 - 4063

Applicant Number

10/058,473

Applicant

Ken Chen et al.

Filing Date

01/28/02

Group Art Unit

2812-2823

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE X APPROXIMATE
ME	5937279	8/10/99	Sawada et al.	438	123	4/21/98
ME	5883001	3/16/99	Jin et al.	438	624	11/7/94
ME	5940277	8/17/99	Farnworth et al.	361	760	12/31/97
ME	6191023	2/20/01	Chen	438	612	11/18/99

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Portion of Pages, Etc.)


EXAMINER

Michelle Estrada

DATE CONSIDERED

8/12/03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.